



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tongbi Jiang et al.

§

Art Unit: 3729

§

Serial No.: 10/689,471

§

Examiner: Minh N. Trinh

§

Filed: October 20, 2003

§

For: A Method For Forming A Stencil
(As Amended)

§

Docket: MCT.0015C2US
97-0524.04US

§

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 20040603

Sir:

In response to the office action mailed June 8, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: August 9, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden